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1765
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)
John E. Lang) Docket No: LAM2P266
Application No: 09/274,194) Examiner: C. Brown
Filed: March 22, 1999) Group Art Unit: 1765
For: METHOD OF REMOVING PHOTORESIST) Date: July 31, 2002
MATERIAL WITH DIMETHYL SULFOXIDE)

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Kay Harlow

CHANGE OF ATTORNEY'S ADDRESS IN APPLICATION

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Sir:

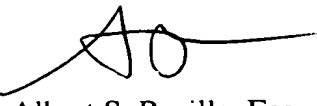
Please send all correspondence for this application as follows:

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Respectfully submitted,
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